

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Toshiharu Furukawa et al. : Date: August 23, 2010  
Group Art Unit: 2811 : IBM Corporation  
Examiner: Ori Nadav : Intellectual Property Law  
Serial No.: 10/777,576 : Dept. 917, Bldg. 006-1  
Filed: February 12, 2004 : 3605 Highway 52 North  
Title: VERTICAL CARBON : Rochester, MN 55901  
NANOTUBE FIELD EFFECT  
TRANSISTORS AND ARRAYS

SUPPLEMENTAL DISCLOSURE STATEMENT

Mail Stop AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of candor and good faith imposed by 37 C.F.R. §1.56, and means of complying therewith according to 37 C.F.R. §§ 1.97 and 1.98, the references listed on the attached PTO Form PTOSB08A are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application.

Even though the Examiner has issued a Notice of Allowance for this application, it is requested that this Supplemental Disclosure Statement be placed in the file of the above-identified patent application. The cited references were cited in a related application to the above-identified case. Applicants wish to make the cited references of record, but it is submitted that the cited references individually or in combination do not disclose nor render obvious the subject matter allowed in the present application, nor require that the prosecution of this application be reopened.

It is believed that no charges or fees are due for this filing; however, if any charges or credits are due with this filing, please apply to Deposit Account 09-0465. If the Office has any questions regarding the foregoing, the Office may contact the undersigned at (507) 253-4661.

Date: August 23, 2010

Respectfully submitted,

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